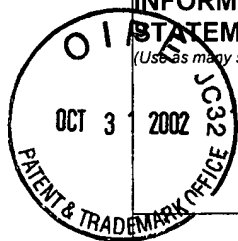


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Application Number 09/712795
Filing Date November 14, 2000
First Named Inventor Craighead, Harold
Group Art Unit 2878
Examiner Name Chu, Changhwa

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Attorney Docket No: 01153.010US1

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EXAMINER

C. Chu

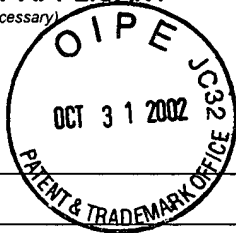
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EXAMINER**DATE CONSIDERED**

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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional) 2 Applicant is to place a check mark here if English language Translation is attached